

Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Atty Docket No.	Serial No.
	YAMAP0983US	10/536,706
	Applicant: HOOPER et al.	
	Filing Date	Group
	May 27, 2005	Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Sub-class	Translation	
						Yes	No

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
Smm	Mayer M. et al.; "Reactive MBE of group III nitrides: high-quality homoepitaxial GaN and ultra-violet light-emitting diodes" Journal of Crystal Growth, North-Holland Publishing Co. Amsterdam, NL, vol. 201-202, May 1999, Pages 318-322, XP004175132.
Smm	Mayer M. et al.; "Device performance of ultra-violet emitting diodes grown by MBE" Journal of Crystal Growth, North-Holland Publishing Co. Amsterdam, NL, vol. 189-190, June 15, 1998, Pages 782-785, XP004148622.
Smm	Abernathy C.R. et al.; "Growth of group III nitrides by metalorganic molecular beam epitaxy" Journal of Crystal Growth, North-Holland Publishing Co. Amsterdam, NL, vol. 178, no. 1-2, June 1, 1997, Pages 74-86, XP004084976.
Smm	Yang Z. et al.; "High-quality GAN and AIN grown by gas-source molecular beam epitaxy using ammonia as the nitrogen source" Journal of Crystal Growth, North-Holland Publishing Co. Amsterdam, NL, vol. 14, no.3, May 1, 1996, Pages 2354-2356 XP000621863.

EXAMINER	<i>S. M. Mahkandeh</i>	DATE CONSIDERED	<i>09/20/2007</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

10/536706
JC06 Rec'd PCT/PTO 27 MAY 2005

Sheet 1

Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Atty Docket No.	Express Mail No.
	YAMAP0983US	EV671713301US
	Applicant: HOOPER et al.	
	Filing Date May 27, 2005	Group Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date if Appropriate
Smm	2002/045340 A1	04/18/2002	Ono Yoshinobu et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Sub-class	Translation	
						Yes	No
Smm	1 164 210 A	19/12/2001	EP				

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
Smm	International Search Report for corresponding Application No. PCT/JP2003/015200, mailed September 3, 2004.

EXAMINER <i>S. M. Maheshwari</i>	DATE CONSIDERED <i>09/20/2007</i>
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